



Image

1762 \$

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Paul B. Mirkarimi et al. Docket No. : CIL-10972
Serial No. : 10/086,614 Art Unit : 1762
Filed : March 1, 2002 Examiner : B. Pianalto
For : Ion-Assisted Deposition Techniques For
The Planarization Of Topological Defects

Commissioner for Patents
P.O. Box 1450
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